

Attorney Docket No. 108298718US  
Disclosure No. 03-0120.00/US

PTO/SB/08A/B (09-06)

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<b>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</b> <i>(Use as many sheets as necessary)</i>				Application Number	10/733,523-Conf. #9060
Sheet	1	of	4	Filing Date	December 10, 2003
				First Named Inventor	Kevin L. Beaman
				Art Unit	1762
				Examiner Name	D. P. Turocy
				Attorney Docket Number	108298718US

<b>U.S. PATENT DOCUMENTS</b>					
Examiner Initials*	Cite No. <sup>1</sup>	Document Number	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number-Knd Code <sup>2</sup> (If known)			
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## INFORMATION DISCLOSURE STATEMENT BY APPLICANT

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				Application Number
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				Art Unit
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<b>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</b> <i>(Use as many sheets as necessary)</i>				Application Number	10/733,523-Conf. #9060
Sheet	3	of	4	Filing Date	December 10, 2003
				First Named Inventor	Kevin L. Beaman
				Art Unit	1762
				Examiner Name	D. P. Turocy
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\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant. \*CITE NO.: Those application(s) which are marked with a single asterisk (\*) next to the Cite No. are not supplied (under 37 CFR 1.98(a)(2)(ii)) because that application was filed after June 30, 2003 or is available in the IFW. <sup>1</sup>Applicant's unique citation designation number (optional). <sup>2</sup>See Kinds Codes of USPTO Patent Documents at [www.uspto.gov](http://www.uspto.gov) or MPEP 801.04. <sup>3</sup>Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). <sup>4</sup>For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. <sup>5</sup>Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST.16 if possible. <sup>6</sup>Applicant is to place a check mark here if English language Translation is attached.

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				Application Number	10/733,523-Conf. #9060
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				First Named Inventor	Kevin L. Beaman
				Art Unit	1762
				Examiner Name	D. P. Turocy
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NON PATENT LITERATURE DOCUMENTS						
Examiner Initials	Cite No. <sup>1</sup>	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.				T <sup>2</sup>
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